



### AMAT CENTURA Epi System

<b>Manufacturer:</b>	Applied Materials
<b>Model:</b>	Centura HT
<b>Vintage:</b>	Fully refurbished
<b>Wafer Size:</b>	200mm (8")
<b>Serial Number:</b>	P669
<b>Process:</b>	Epitaxial (EPI), reduced pressure (RP)
<b>Configuration:</b>	Widebody loadlocks HP robot OTF STD Epi gas panel Position A: Epitaxial (EPI) RP Position B: Epitaxial (EPI) RP Position C: Epitaxial (EPI) RP Position F: cooldown Epitaxial (EPI) chamber detail: <ul style="list-style-type: none"><li>* R3.4 rotation assy</li><li>* Variable Speed Blower</li><li>* Quartz Pyrometer Kit</li><li>* USHIO lamps</li><li>* Standard susceptor by Covalent</li><li>* Hollow silicon carbide lift pins</li><li>* NCP susceptor support shaft</li><li>* Silicon carbide removable tips</li><li>* Stainless steel exhaust inserts</li></ul>

